



Docket No.: OMY-013
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Kunie Ogata et al.

Application No.: 09/963,527

Group Art Unit: 1756

Filed: September 27, 2001

Examiner: J. Ruggles

For: RESIST PATTERN FORMING METHOD
(amended)

RECEIVED
FEB 12 2004
TC 1700

SUPPLEMENTAL AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)
SUBMITTED WITH RCE

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RECEIVED
MAR 18 2004
TC 1700

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated October 8, 2003 (Paper No. 10), and the Advisory Action dated February 5, 2004 (Paper No. 01282004), and Supplemental to the Amendment filed January 8, 2004, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.